Analysis is used for it purpose. Therefore the elemental electrolyte composition are determined from phase concentrations. There are some analytical problems of XRD analysis. A mineralogical content a sample of cooling electrolyte may include until ten phases. Phase content depends on CR, elemental content and cooling speed. High speed of cooling induces that some Ca-contained phases are half-amorhous and some Li-contained phases have a heavy overlapping of all strong lines. Several different quantitative XRD or combined XRD and XRF [1] methods based on using of calibration standard samples have been developed for bath control at Russia aluminum smelters. Standard samples with precision values of phase concentrations are problem too because their getting by mix in the bath. So, standard samples are determined from phase concentrations. There are combined XRD and XRF [1] methods based on using of calibration standard samples and their implementation this methods and decision of mentioned problems including phase quantification of industrial electrolytes as standard.

Keywords: quantitative phase analysis, aluminum bath ratio, cryolite ratio

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**Diffraction experiments with high-energy X-rays during PVT growth of SiC**

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An inductively heated PVT growth furnace was built for the growth of SiC crystals by the modified Lely method. Crystals of 2 inch diameter can be grown. The furnace is designed for in situ diffraction experiments and absorption contrast imaging with high-energy x-rays (50keV and higher) during crystal growth. With this furnace placed in the beam of a laboratory high-energy x-ray tungsten anode, the growth process can be monitored by x-ray diffraction, e.g. with the white beam Laue diffraction technique in focussing or non-focussing mode. Absorption contrast images of the crystal boule give information about the growth velocity. Diffraction and absorption contrast images are recorded in intervals of 15 minutes exposure time by a CCD-detector and off-line readable image plates. Up to now, the diffraction images allow the ‘real-time’ visualisation of the thermo-mechanical response of the crystal to variations of growth parameters like argon pressure and temperature changes. Polytype changes like the 6H to 15R transition can be observed in situ in the diffraction patterns. The observation of the characteristic tungsten emission lines in the diffraction image allows to observe the macroscopic bending of the lattice planes over the crystal wafer and to determine its radius of curvature. In the initial stages of growth the shape of the developing growth front seems to be susceptible to parameter changes like e.g. repeated growth interruptions. During growth interruptions the mechanical stress is relieved. Thus with the aid of diffraction on growing SiC crystals we are able to monitor in situ transient temperature phenomena and their response to changes in the external parameter values which have been chosen for crystal growth.

Keywords: silicon carbide, crystal growth and perfection, high-energy x-ray diffraction

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**Dislocation assisted intermetallic layer formation at the interface of Sn-Pb solder and Cu**

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When near eutectic Sn-Pb Solder containing solid resin as flux is applied on Cu substrate an intermetallic layer comprising mainly of Cu-Sn & Cu,Sn is formed at the interface the thickness of which determines the quality of soldering (dry or perfect). This work reports that dislocation on the Sn component favours the formation of intermetallic layer. The average dislocation density was calculated from the xrd profile of 101 line of beta-tin component of a perfectly & dry soldered Cu strip using the 4th moment method proposed by groma & Borbely, 2001. The thickness of the intermetallic layer was measured using scanning electron microscopy.

Reference: 

Keywords: dislocations, material chemistry, metal alloys

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**Characterization of strain in cubic thin film with <hkl> fiber texture in anisotropic stress state**

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A technique for obtaining residual stress in poly-crystalline materials was proposed at AsCA’ 07 (P05-019). The technique provides the residual stress based on Reuss model through an examination of overlapping reciprocal lattice points which meet Bragg condition with the Laue symmetries. This paper shows the residual stress in TiN with <110> fiber texture or other fiber textures in cubic having the Laue symmetry m-3m and analyzes the strain from the peaks splits and peak broadening in the XRD profiles with the technique. Thus the equivalent reflections of the crystallites form a ring around the fiber axis in reciprocal lattice space(RLS). In the case of TiN with <110> axis, the reflections are divided into two groups by the orientation of their crystallites. The crystallites are deformed differently due to the elastic constants determined by their orientations. Type II in Fig. 1 shows the peaks of the two groups shift in opposite directions away from the unstrained peak. Thus the ring is divided into two rings as shown in Fig.2. With the above consideration of RLS, the described technique suggests its application to characterizing the strain of general poly-crystalline materials.

Keywords: silicon carbide, crystal growth and perfection, high-energy x-ray diffraction